

X-RAY POWDER DIFFRACTION COURSES

Fundamentals of XRD I: 1 - 5 June 2026 Advanced Methods in XRD II: 8 - 12 <u>June 2026</u>

Techniques & Skills to Maximize Results!



FUNDAMENTALS COURSE OUTLINE

- Production and properties of X-rays
- Production of monochromatic X-radiation
- Components of the diffraction pattern
- The powder diffractometer
- Acquisition of good diffraction data
- Qualitative phase identification
- Industrial applications of X-ray powder diffraction
- Hands-on use of computers for demonstration of the latest software
- Data mining with the PDF



ADVANCED METHODS COURSE OUTLINE

- Brief review of fundamentals
- Factors affecting accuracy of measured 20 values
- Factors affecting intensities of diffraction peaks
- Use of computer methods for data reduction and qualitative phase identification
- Advanced data mining with the PDF
- Exploration of powder pattern indexing methods
- Quantitative analysis
- Structure solution and refinement using the Rietveld method

Please note: A minimum of 10 registrants per course is required, otherwise the course will be cancelled and your registration fee will be refunded. You will be notified of a course cancellation no later than two weeks prior to the start of the course.

See website for early registration deadlines.

ATTENDEES WILL RECEIVE THE FOLLOWING:

Selected Resources for X-ray Diffraction – a valuable online link to the compilation of software for data analysis and interpretation, and ICDD's Methods and Practices – a compendium of articles and reports relating to applications and techniques in XRD.



Contact: Elizabeth Dempsey

12 Campus Boulevard • Newtown Square, PA 19073 USA Phone: +610.325.9814 • Toll-free (U.S. & Canada) 866.378.9331 Fax: +610.325.9823 • www.icdd.com • education@icdd.com







ICDD, the ICDD logo, PDF, Materials Data, JADE, Denver X-ray Conference, Denver X-ray Conference logo, and Materials Data-JADE-SM-WPF logo are registered in the U.S. Patent and Trademark Office. Powder Diffraction File, MDI, and the MDI-Materials Data logo are trademarks of the JCPDS-International Centre for Diffraction Data. ©2025 JCPDS-International Centre for Diffraction Data.